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	Lingyi A. Zheng	4539
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**OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)**

Examiner Initial		Non-Patent Document
<i>gml</i>	A1	Van Zant, Peter, <i>Microchip Fabrication, A Practical Guide to Semiconductor Processing</i> , 4 <sup>th</sup> ed., McGraw-Hill, New York, pp. 337-357 and 363-366 (2000)
<i>gml</i>	A2	Wolf and Tauber, <i>Silicon Processing for the VLSI Era, Vol. 1: Process Technology</i> , 2 <sup>nd</sup> ed., Lattice Press, Sunset Beach, Cal., pp. 202-206 and 371-433 (2000)

Examiner Initials	<i>Quinn M. Kennedy</i>	Date Considered	<i>July 13, 2004</i>
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			